

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Kim et al.	Examiner:	Thomas, Toniae M
Serial No:	10/728,517	Group Art Unit:	2822
Filed:	December 5, 2003	Docket:	8836-203 (IE12204-US)
For:	<b>CLEANING SOLUTION AND METHOD FOR SELECTIVELY REMOVING LAYERS IN A SILICIDATION PROCESS</b>		

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT TO OFFICE ACTION**

This Amendment is submitted in response to the September 27, 2006 Final Office Action issued by the United States Patent and Trademark Office in connection with the above-identified application. Applicants respectfully request reconsideration of the claim rejections based on the following amendment and remarks.